



JFW

PATENT

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

CHRISTIAN KRUEGER  
NIELS-WIELAND HAUPTMANN  
THOMAS BECK

Serial No.: 10/602,191

Filed: June 24, 2003

For: METHOD OF REDUCING  
CONTAMINATION-INDUCED  
PROCESS VARIATIONS DURING ION  
IMPLANTATION

Examiner: William D. Coleman

Group Art Unit: 2823

Att'y Docket: 2000.106800/DE0123

Customer No.: 23720

**RESPONSE TO OFFICE ACTION DATED DECEMBER 10, 2004**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING  
37 C.F.R 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

March 2, 2005

Date

  
Signature

This paper is submitted in response to the Office Action dated December 10, 2004, for which the three-month date for response is March 10, 2005.

It is believed that no fee is due; however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be required for any reason relating to this document, the Director is authorized to deduct said fees from Advanced Micro Devices, Inc. Deposit Account No. 01-0365/DE0123. In the event the monies in that account are insufficient, the Director is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.106800.

Reconsideration of the application in view of the following amendments and remarks is respectfully requested.